

<b>Notice of References Cited</b>	Application/Control No. 10/512,076		Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner SHEETAL R. RANGREJ		Art Unit 3686	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,441,047	08-1995	David et al.	600/483
*	B	US-2008/0021740	01-2008	Beane et al.	705/003
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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